

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812 Examiner: To be assigned

In Re PATENT APPLICATION Of:

Applicant(s)	: Muh Wang LIANG et al.)
Serial No.	: 09/619,388)
Filed	: July 19, 2000)) STATUS REQUEST
For	: APPARATUS FOR LOADING/UNLOADING WAFERS TO AND FROM SEMICONDUCTOR FABRICATION EQUIPMENT	STATUS REQUEST
Attorney Re	f: LIE 105)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

THE TANK Please let us know the status of the above-identified application and when an be expected. Please respond via facsimile or e-mail Tonya Harris (Docketing Manager) at

tonya@rabinchamp.com.

Respectfully submitted,

Steven M. Ralin

January 21, 2004

Date

Please cherge any furthor E SMR:dt

fec to our Deposit Account

Steven M. Rabin

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